



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/421,625
Filing Date October 19, 1999
Inventor..... Eugene P. Marsh
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2811
Examiner H. Vu
Attorney's Docket No. MI22-1284
Title: Circuitry and Capacitors Comprising Roughened Platinum Layers

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the reference listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

This Supplemental Information Disclosure Statement is being filed after the filing of the Request for Continued Examination (RCE) Application and before receipt of the first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of this reference is respectfully requested.

Respectfully submitted,

Date: 22 Jun 2005



James E. Lake
Reg. No. 44,854

Form PTO-140		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1284		SERIAL NO. 09/421,625	
<div style="position: relative; height: 100px;"> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; color: black; font-weight: bold; line-height: 1;"> O I P E J C I 2 JUN 22 2005 PATENT & TRADEMARK OFFICE </div> </div>					LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			
					APPLICANT Eugene P. Marsh			
					FILING DATE October 19, 1999		GROUP 2811	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
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	AI							
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FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR		Toru Nasu, et al, Study of Pt Bottom Electrodes Using High-Temperature Sputtering for Ferroelectric Memories with SrBi2Ta2O9 (SBTO) Film, Jpn. J. Appl. Phys. Vol. 37 (1998) pp. 4144-4148.					
	AS							
EXAMINER				DATE CONSIDERED				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								